

Docket No.: 60188-705

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277  
Manabu TAKAHASHI, et al. : Confirmation Number:  
Serial No.: : Group Art Unit:  
Filed: November 19, 2003 : Examiner:  
For: SEMICONDUCTOR DEVICE AND CONTROL METHOD

**CLAIM OF PRIORITY**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

**Japanese Patent Application No. 2002-335612, filed November 19, 2002**

A Certified copy will be filed in due course.

Respectfully submitted,

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